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APPLICANTS

Shunpei Yamazaki, Atsugi-shi, JAPAN;

Hisashi Ohtani, Atsugi-shi, JAPAN;

Koichiro Tanaka, Atsugi-shi, JAPAN; Kenji Kasahara, Atsugi-shi, JAPAN;

Ritsuko Kawasaki, Atsugi-shi, JAPAN;

** CONTINUING DATA *****

This application is a DIV of 09/932,935 08/21/2001 PAT 6,753,212
 which is a DIV of 09/635,422 08/10/2000 PAT 6,730,550

** FOREIGN APPLICATIONS *****

JAPAN 11-229518 08/13/1999

JAPAN 11-250940 09/03/1999

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 18	TOTAL CLAIMS 109	INDEPENDENT CLAIMS 30
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: <i>gls</i>				

ADDRESS

31780
 ERIC ROBINSON
 PMB 955
 21010 SOUTHBANK ST.
 POTOMAC FALLS, VA
 20165

TITLE

LASER APPARATUS, LASER ANNEALING METHOD, AND MANUFACTURING METHOD OF A
 SEMICONDUCTOR DEVICE

☐ All Fees